

<b>Notice of References Cited</b>	Application/Control No. 10/588,779		Applicant(s)/Patent Under Reexamination YAMAGUCHI ET AL.	
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#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,221,050 A	06-1993	Jeffries et al.	239/708
*	B	US-5,218,290 A	06-1993	Beckert et al.	324/115
*	C	US-5,704,554 A	01-1998	Cooper et al.	239/690.1
*	D	US-6,318,647 B1	11-2001	Gaw et al.	239/690
*	E	US-2002/0100815 A1	08-2002	Doebler et al.	239/67
*	F	US-6,595,208 B1	07-2003	Coffee et al.	128/203.12
*	G	US-2004/0057720 A1	03-2004	Westerweck et al.	396/448
*	H	US-6,744,046 B2	06-2004	Valaskovic et al.	250/288
*	I	US-6,911,132 B2	06-2005	Pamula et al.	204/600
*	J	US-7,091,430 B1	08-2006	Haizima et al.	200/6A
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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